

<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)		Docket Number (Optional) <b>MM4641</b>	Application Number <b>10/678,407</b>
		Applicant(s) <b>Teruhiko Fujisawa, et al.</b>	
		Filing Date <b>October 3, 2003</b>	Group Art Unit <b>3629</b>
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)			
NM NM	AA	Japanese laid-open Pub. No. 2001-175819, 29/06/2001, Hitachi Ltd. (US 6488204, US 6604679)	
	AB	Japanese laid-open Pub. No. 9-106422, English abstract, 22/04/1997, Hitachi Ltd.	
	AC	Japanese laid-open Pub. No. 2002-83145, 22/03/2002, Hitachi Ltd. (US 2002-0029191)	
	AD	Japanese laid-open Pub. No. 2002-123685, 26/04/2002 (US 2002-0046161)	
	AE	Japanese laid-open Pub. No. 61-234466, English abstract, 18/10/1986, Omron Tateisi Electronics Co.	
	AF	Japanese laid-open Pub. No. 2000-181982, English abstract, 30/06/2000, Oki Electric Ind Co. Ltd.	
	AG	Japanese laid-open Pub. No. 2001-273442, English abstract, 05/10/2001, JCB:KK	
EXAMINER <i>[Signature]</i>		DATE CONSIDERED <i>10/29/07</i>	
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			





-(Use several sheets if necessary)

**MM4641**

Application Number

**Applicant(s)**

**Teruhiko FUJISAWA, et al**

**Filing Date**

**Concurrently Herewith**

### Group Art Unit

## U.S. PATENT DOCUMENTS

## FOREIGN PATENT DOCUMENTS

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

**EXAMINER**

DATE CONSIDERED

10/29/07

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.